

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
L1	12	(crystallization adj apparatus) and semiconductor and phase	USPAT	OR	OFF	2005/02/04 13:09
L2	144	(117/7).CCLS.	USPAT	OR	OFF	2005/02/04 13:09
L3	667	(438/166).CCLS.	USPAT	OR	OFF	2005/02/04 13:09